

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT: Spooner at al.

GROUP: 2811

SERIAL NO: 10/007,585

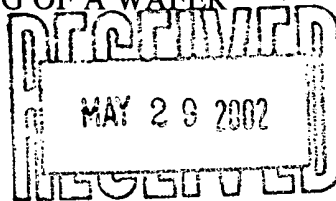
EXAMINER: UNKNOWN

FILED: 12/05/01



FOR: METHOD AND DEVICE FOR PROTECTING MICRO ELECTROMECHANICAL SYSTEMS STRUCTURES DURING DICING OF A WAFER

Assistant Commissioner of Patents  
Washington, D.C. 20231



Sir:

INFORMATION DISCLOSURE STATEMENT

In compliance with 37 C.F.R. §§1.56, 1.97, and 1.98, Applicant submits copies of the documents listed on the attached Form PTO-1449.

The Commissioner is authorized to charge Deposit Order Account No. 19-0079 for any further fee that is required.

Respectfully submitted,

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I hereby certify that this paper (along with any paper referred to as being attached or enclosed) is being deposited with the United States Postal Service on the date shown below with sufficient postage as first class mail in an envelope addressed to the Commissioner of Patents and Trademarks, Washington, D.C. 20231.

*Emily C. Porell*  
Emily C. Porell

01/30/02  
Date

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